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**CHEMICAL MECHANICAL POLISHING PROCESS**

Appl. No. : 10/711,392 Confirmation No. 5391  
Applicant : Chia-Lin Hsu,  
Teng-Chun Tsai  
Filed : September 16, 2004  
TC/A.U. : 3723  
Examiner : Jacob K. Ackun Jr.  
Docket No. : NAUP0633USA0  
Customer No. : 27765

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office action of July 5, 2005, please amend the above-identified  
5 application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of  
this paper.

Remarks/Arguments begin on page 4 of this paper.

Do Not Enter - J. Ackun 10/7/05